



JPM

PATENT
Customer No. 22,852
Attorney Docket No. 02887.0259

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Junji SUGAMOTO et al.)	Group Art Unit: 2891
)	
Application No.: 10/706,090)	Examiner: Lee, Granvill D
)	
Filed: November 13, 2003)	Confirmation No. 7292
)	
For: SEMICONDUCTOR WAFER)	
TREATMENT METHOD,)	
SEMICONDUCTOR WAFER)	
INSPECTION METHOD,)	
SEMICONDUCTOR DEVICE)	
DEVELOPMENT METHOD AND)	
SEMICONDUCTOR WAFER)	
TREATMENT APPARATUS)	

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed September 22, 2005, the period for response to which extends through December 22, 2005, please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this paper.

Amendments to the Drawings are made in the attached replacement sheets and are discussed in the **Remarks** section of this paper.

Remarks begin on page 11 of this paper.

Attachments to this Amendment: Ten (10) sheets of drawings, each labeled "Replacement Sheet," containing amended Figs. 1-16.